



(22) Date de dépôt/Filing Date: 2011/05/06

(41) Mise à la disp. pub./Open to Public Insp.: 2011/11/17

(45) Date de délivrance/Issue Date: 2023/04/04

(62) Demande originale/Original Application: 2 811 609

(30) Priorités/Priorities: 2010/05/08 (US61/332,755);
2011/03/17 (US61/453,852)

(51) Cl.Int./Int.Cl. A61B 5/05 (2021.01),
A61B 5/00 (2006.01), A61B 5/0531 (2021.01)

(72) Inventeurs/Inventors:

SARRAFZADEH, MAJID, US;
KAISER, WILLIAM, US;
MEHRNIA, ALIREZA, US;
BATES-JENSEN, BARBARA, US;
WANG, FRANK, US;

...

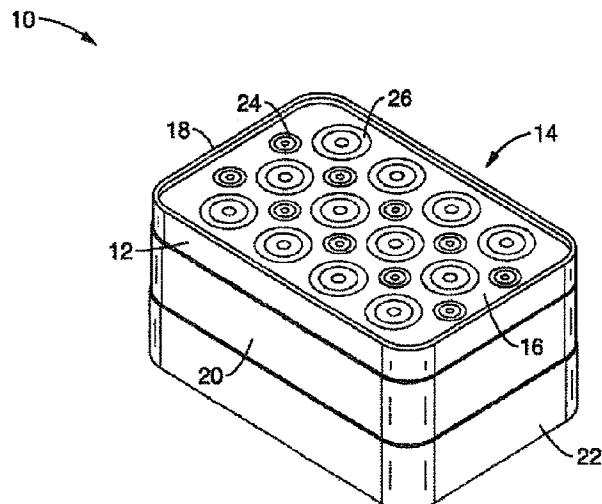
(73) Propriétaires/Owners:

THE REGENTS OF THE UNIVERSITY OF CALIFORNIA,
US;
BRUIN BIOMETRICS, LLC, US

(74) Agent: PERRY + CURRIER

(54) Titre : APPAREIL DE DETECTION DE SCANNER SEM, SYSTEME ET METHODOLOGIE POUR LA DETECTION
PRECOCE DES ULCERES

(54) Title: SEM SCANNER SENSING APPARATUS, SYSTEM AND METHODOLOGY FOR EARLY DETECTION OF
ULCERS



(57) Abrégé/Abstract:

A handheld, conforming capacitive sensing apparatus configured to measure Sub- Epidermal Moisture (SEM) as a mean to detect and monitor the formation of pressure ulcers. The device incorporates an array of electrodes which are excited to measure and scan SEM in a programmable and multiplexed manner by a battery-less RF-powered chip. The scanning operation is initiated by an interrogator which excites a coil embedded in the apparatus and provides the needed energy burst to support the scanning/reading operation. Each electrode measures the equivalent sub-epidermal capacitance corresponding and representing the moisture content.

(72) Inventeurs(suite)/Inventors(continued): LAM, YEUNG, US; FLESCH, MICHAEL, US; BOYSTAK, JOSEPH, US

ABSTRACT

A handheld, conforming capacitive sensing apparatus configured to measure Sub-Epidermal Moisture (SEM) as a mean to detect and monitor the formation of pressure ulcers. The device incorporates an array of electrodes which are excited to measure and scan SEM in a programmable and multiplexed manner by a battery-less RF-powered chip. The scanning operation is initiated by an interrogator which excites a coil embedded in the apparatus and provides the needed energy burst to support the scanning/reading operation. Each electrode measures the equivalent sub-epidermal capacitance corresponding and representing the moisture content.

**SEM SCANNER SENSING APPARATUS, SYSTEM AND METHODOLOGY FOR
EARLY DETECTION OF ULCERS**

[0001]

[0002]

5 [0003]

[0004] BACKGROUND OF THE INVENTION

[0005] 1. Field of the Invention

[0006] This invention pertains generally to monitoring skin pressure ulcers and

more particularly to skin ulcer monitoring via measurement of Sub-epidermal Moisture (SEM).

[0007] 2. Description of Related Art

[0008] Patients' skin integrity has long been an issue of concern for nurses and in nursing homes. Maintenance of skin integrity has been identified by the American Nurses Association as an important indicator of quality nursing care. Meanwhile, pressure ulcers remain a major health problem particularly for hospitalized older adults. When age is considered along with other risk factors, the incidence of pressure ulcers is significantly increased. Overall incidence of pressure ulcers for hospitalized patients ranges from 2.7% to 29.5%, and rates of greater than 50% have been reported for patients in intensive care settings. In a multicenter cohort retrospective study of 1,803 older adults discharged from acute care hospitals with selected diagnoses, 13.2% (i.e., 164 patients) demonstrated an incidence of stage I ulcers. Of those 164 patients, 38 (16%) had ulcers that progressed to a more advanced stage. Pressure ulcers additionally have been associated with an increased risk of death one year after hospital discharge. The estimated cost of treating pressure ulcers ranges from \$5,000 to \$40,000 for each ulcer, depending on severity.

[0009] Therefore, there is an urgent need to develop a preventive solution to measure moisture content of the skin as a mean to detect early symptoms of ulcer development.

BRIEF SUMMARY OF THE INVENTION

[0010] An aspect of the present invention is a smart compact capacitive sensing conforming handheld apparatus configured to measure Sub-epidermal Moisture (SEM) as a mean to detect and monitor the development of pressure ulcers. The device incorporates an array of electrodes which are excited to measure and scan SEM in a programmable and multiplexed manner by a battery-less RF-powered chip. The scanning operation is initiated by an interrogator which excites a coil embedded in the apparatus and provides the needed energy burst to support the scanning/reading operation. Each embedded electrode measures the equivalent sub-epidermal capacitance

corresponding and representing the moisture content of the target surface.

5 [0011] An aspect of this invention is the in situ sensing and monitoring of skin or wound or ulcer development status using a wireless, biocompatible RF powered capacitive sensing system referred to as smart SEM imager. The present invention enables the realization of smart preventive measures by enabling early detection of ulcer formation or inflammatory pressure which would otherwise have not been detected for an extended period with increased risk of infection and higher stage ulcer development.

10 [0012] In one beneficial embodiment, the handheld capacitive sensing imager apparatus incorporates pressure sensing components in conjunction with the sensing electrodes to monitor the level of applied pressure on each electrode in order to guarantee precise wound or skin electrical capacitance measurements to characterize moisture content. In summary, such embodiment would enable new capabilities including but not limited to: 1) 15 measurement capabilities such as SEM imaging and SEM depth imaging determined by electrode geometry and dielectrics, and 2) signal processing and pattern recognition having automatic and assured registration exploiting pressure imaging and automatic assurance of usage exploiting software systems providing usage tracking.

20 [0013] One major implication of this sensor-enhanced paradigm is the ability to better manage each individual patient resulting in a timelier and more efficient practice in hospitals and even nursing homes. This is applicable to patients with a history of chronic wounds, diabetic foot ulcers, pressure ulcers or post-operative wounds. In addition, alterations in signal content may be integrated 25 with the activity level of the patient, the position of patient's body and standardized assessments of symptoms. By maintaining the data collected in these patients in a signal database, pattern classification, search, and pattern matching algorithms can be developed to better map symptoms with alterations in skin characteristics and ulcer development. This approach is not limited to the specific condition of ulcer or wound, but may have broad 30 application in all forms of wound management and even skin diseases or

treatments.

[0014] One aspect is apparatus for sensing sub-epidermal moisture (SEM) from a location external to a patient's skin. The apparatus includes a bipolar RF sensor embedded on a flexible substrate, and a conformal pressure pad disposed adjacent and underneath the substrate, wherein the conformal pressure pad is configured to support the flexible substrate while allowing the flexible substrate to conform to a non-planar sensing surface of the patient's skin. The apparatus further includes interface electronics coupled to the sensor; wherein the interface electronics are configured to control emission and reception of RF energy to interrogate the patient's skin.

[0015] Another aspect is a method for monitoring the formation of pressure ulcers at a target location of a patient's skin. The method includes the steps of positioning a flexible substrate adjacent the target location of the patient's skin; the flexible substrate comprising one or more bipolar RF sensors; conforming the flexible substrate to the patient's skin at the target location; exciting the one or more bipolar RF sensor to emit RF energy into the patient's skin; and measuring the capacitance of the skin at the target location as an indicator of the Sub-Epidermal Moisture (SEM) at the target location.

[0016] Further aspects of the invention will be brought out in the following portions of the specification, wherein the detailed description is for the purpose of fully disclosing preferred embodiments of the invention without placing limitations thereon.

BRIEF DESCRIPTION OF THE SEVERAL VIEWS

OF THE DRAWING(S)

[0017] The invention will be more fully understood by reference to the following drawings which are for illustrative purposes only:

[0018] FIG. 1 illustrates an assembled perspective component view of the SEM Scanner of the present invention.

[0019] FIG. 2 illustrates a perspective view of a Kapton-based conforming sensing substrate assembly of the present invention.

[0020] FIG. 3 shows a top view of an exemplary concentric sensing electrode

in accordance with the present invention.

[0021] . FIG. 4 illustrates a side view of a flex stack-up for the Kapton-based conforming sensing substrate shown in FIG. 2.

[0022] FIG. 5 illustrates a side view of an alternative flex stack-up for a 5 Kapton-based conforming sensing substrate.

[0023] FIG. 6 shows a top view of two-electrode sensing Kapton-based flex sensor substrates for three alternative types of capacitive sensing concentric electrodes.

[0024] FIG. 7 illustrates an exploded perspective component view of the SEM 10 scanner of FIG. 1.

[0025] FIG. 8 illustrates a schematic side view of the SEM scanner of FIG. 1.

[0026] FIG. 9 illustrates a schematic side view of the SEM scanner of FIG. 8 in contact with subject skin.

[0027] FIG. 10 illustrates a perspective view of an assembled SEM scanner 15 with an alternative array of sensors in accordance with the present invention.

[0028] FIG. 11 is a plot of normalized responses of the tested electrodes of the present invention.

[0029] FIG. 12 is a graph of measured equivalent capacitance for dry volar arm for three different concentric sensor electrodes.

[0030] FIG. 13 is a plot of time dependent fractional change in capacitance 20 relative to dry skin for three different concentric sensor electrodes (after 30 minutes of applying lotion).

[0031] FIG. 14 is a plot of time dependent fractional change in capacitance relative to dry skin for three different concentric sensor electrodes (after 15 25 minutes of applying lotion).

[0032] FIG. 15 is a plot of fractional change vs. time.

[0033] FIG. 16 shows a SEM scanner electrode system and electrode layering providing proper shielding from interference.

[0034] FIG. 17 shows an SEM scanner mechanical compliance for electrodes 30 developed to enable probing of bony prominence.

DETAILED DESCRIPTION OF THE INVENTION

5 [0035] In one exemplary embodiment, a smart handheld capacitive sensing device according to the present invention employs a programmable sensing electrode array. This is based on methods that use an interrogator to excite the embedded electrodes.

10 [0036] FIG. 1 illustrates an SEM scanning/sensing apparatus 10 according to the present invention. The scanner 10 comprises five main components, including a top silicone edge sealing gasket 18 encircling a Kapton-based sensing substrate 16, which rests on a conformal silicone pressure pad 12. A thick annular silicone spacer 20 is disposed under pressure pad to provide free space for the pressure pad to deform. The bottom layer comprises an interface electronics package enclosure 22 that houses interface circuitry for interrogating and transmitting data for evaluation. These five main components are described in further detail below.

15 [0037] In the embodiment shown in FIG. 1, an array 14 of individual RF electrode sensors 24 and 26 is embedded on a flexible biocompatible substrate 16. Substrate 16 may comprise a laminated Kapton (Polyimide) chip-on-flex.

20 [0038] FIG. 2 illustrates one embodiment of a Kapton sensor substrate 16a that comprises an array 14 of differing sized concentric sensing electrodes. A flexible biocompatible Polyimide or Kapton substrate 32 comprises a layer of sensing pads 14 and 15 coated on one side with an ultra thin cover layer 30 of Polyimide (e.g. CA335) to isolate pads electrodes 14,15 from direct moisture contact and also to provide a uniform contact surface.

25 [0039] In FIG. 2, sample capacitive sensing electrodes 14 are shown in different sizes (e.g. 24, 26, and 29), which are manipulated to achieve and sense different depths of skin. Sensing electrodes 14 may comprise any number of different shape and configurations, such as the concentric circles of array 14, or the interdigitating fingers of sensor 15.

30 [0040] FIG. 3 illustrates a close-up top view of a concentric sensing pad 26 in accordance with the present invention. Pad 26 comprises a bipolar

configuration having a first electrode 36 comprising an outer annular ring disposed around a second inner circular electrode 38. Outer ring electrode 36 has an outer diameter D_o and an inner diameter D_i that is larger than the diameter D_c of the circular inner electrode 38 to form annular gap 40. Inner 5 circular electrode 38 and outer ring electrode 36 are coupled electrically to interface electronics in the interface electronics package 22. As shown in greater detail in FIGS. 4 and 5, electrodes 36 and 38 are disposed on separate layers within the substrate assembly 16.

[0041] The dimensions of the sensor pads 24, 26 generally correspond to the 10 depth of interrogation into the derma of the patient. Accordingly, a larger diameter pad (e.g. pad 26 or 29) will penetrate deeper into the skin than a smaller pad. The desired depth may vary depending on the region of the body being scanned, or the age, skin anatomy or other characteristic of the patient. Thus, SEM scanner 10 may comprise an array of different sized pads 15 (e.g. small pads 24 and medium sized pads 26 shown in FIG. 1) each individually coupled to the interface electronics package 22.

[0042] FIG. 4 illustrates side view of a flex stack-up for a Kapton based 20 substrate assembly 16, where thin adhesive layers 42 are used to attach a Kapton layer 32 in between copper layers 44 and 46, all of which are disposed between upper coverlay 30 and lower coverlay 48. A stiffener 50 is disposed under lower coverlay 48, being positioned directly under copper layer 46 of the sensing pads. The stiffener 50 forms a rigid portion of the substrate where 25 sensing pad array 14, connectors (e.g. connectors 66, 76, or 86 shown in FIG. 6) and interfacing (e.g. lead wires 34) are located, so that these areas do not deform, whereas the rest of the substrate is free to deform. The top copper layer 44 is used to etch out electrode array 14 and corresponding copper routing 34 to the connectors. The bottom copper layer 46 preferably comprises a crisscross ground plane to shield electrode array 14 from unwanted 30 electromagnetic interference.

[0043] In one embodiment, the flex substrate 16 assembly comprises Pyralux 30 FR material from Dupont. In an exemplary configuration, approximately 5mil

thick FR9150R double-sided Pyralux FR copper clad laminate is used as the Kapton substrate. Top overlay 30 comprises Pyralux 5mil FR0150 and the bottom overlay 48 comprises 1 mil FR0110 Pyralux. The thickness of the top FR0150 overlay 30 is an important parameter as it affects the sensitivity of 5 sensing electrodes in measuring skin moisture content. Copper layers 44, 46 are generally 1.4mil thick, while adhesive layers 42 are generally 1 mil thick. The stiffener 50 is shown in FIG. 4 is approximately 31 mil thick.

[0044] FIG. 5 shows a side view of a preferred alternative flex stack-up for a 10 Kapton based substrate 120, where thin adhesive layers 42 (1 mil) are used to attach an 18 mil Kapton layer 122 in between 1.4 mil copper layers 44 and 46, all of which are disposed between 2 mil upper overlay 30 and 1 mil lower overlay 48. A stiffener 50 is disposed under lower overlay 48, being positioned directly under copper layer 46 of the sensing pad. The 31 mil FR4 15 stiffener 126 forms a rigid portion of the substrate under the array 14 of sensing pads, connectors 66 and interfacing 34. A 2 mil layer of PSA adhesive 124 is used between the bottom overlay 48 and stiffener 126. The layering of assembly 120 is configured to provide proper shielding from interference.

[0045] FIG. 6 shows a top view of three separate and adjacently arranged 20 concentric bipolar electrode sensing Kapton-based flex pads 60, 70 and 80 having different sized capacitive sensing concentric electrodes. Pad 60 comprises a substrate having two large concentric electrodes 62 wired through substrate 64 via connectors 34 to lead line inputs 66. Pad 70 comprises a substrate having two medium concentric electrodes 72 wired through substrate 74 to lead line inputs 76. Pad 80 comprises a substrate having two 25 small concentric electrodes 82 wired through substrate 84 to lead line inputs 86. The configuration shown in FIG. 6 is optimized for cutting/manufacturing and also to avoid interference between data lines and sensors. Each of the bipolar electrode pads is individually wired to the electronics package 22 to allow for independent interrogation, excitation, and data retrieval.

[0046] FIG. 7 illustrates an exploded perspective component view of the SEM 30 scanner 10. The silicone edge sealing gasket 18 is applied over the Kapton

sensor substrate assembly 16 to seal and shield the edge interface connectors through which interface electronics package 22 excite and controls the sensing electrode array 14. The Kapton sensor substrate assembly 16 rests on a conformal silicone pressure pad 12 that provides both support and 5 conformity to enable measurements over body curvature and bony prominences.

10 [0047] In one beneficial embodiment, pressure sensor 11 may be embedded under each sensing electrode 24, 26 (e.g. in an identical array not shown), sandwiched between Kapton sensor substrate 26 and the conformal silicone pressure pad 28 to measure applied pressure at each electrode, thus ensuring a uniform pressure and precise capacitance sensing.

15 [0048] Lead access apertures 28 provide passage for routing the connector wires (not shown) from the substrate connectors (e.g. 66, 76, 86) through the pressure pad 12, annular spacer 20 to the interface electronics 22.

20 [0049] The annular silicone spacer 20 comprises a central opening 27 that provides needed spacing between the conformal silicone pressure pad 12 and the interface electronics package 22 to allow the pressure pad 12 and flexible substrate to conform in a non-planar fashion to conduct measurements over body curvatures or bony prominences.

25 [0050] In one embodiment, the interface electronics package 22 is connected to a logging unit or other electronics (not shown) through wire-line USB connector 56.

30 [0051] The interface electronics package 22 preferably comprises an enclosure that contains all the electronics (not shown) needed to excite, program and control the sensing operation and manage the logged data. The electronics package 22 may also comprise Bluetooth or other wireless communication capabilities to allow for transfer of sensing data to a computer or other remote device. Docked data transfer is also contemplated, in addition to real-time Bluetooth transfer. A gateway device (not shown) may be used for communicating with the SEM device 10 and data formatting prior to upload to a computer or backend server.

[0052] FIG. 8 is a schematic side view of the SEM scanner 10 in the nominal configuration, showing the edge gasket 18 over Kapton substrate 16, and lead access apertures 28, which provide access through annular spacer 20 and conformal pad 12 to electronics 22.

5 **[0053]** FIG. 9 illustrates a schematic side view of the SEM scanner 10 in contact with the target subject 25. The annular silicone spacer 20 provides enough spacing for conforming silicone pad 12 to conform to the target surface 25. The conforming silicone pad 12 enables continuous contact between the substrate 16 and patient's skin 25, thus minimizing gaps between
10 the substrate 16 and patient's skin 25 that could otherwise result in improper readings of the patient anatomy. Electrode array 14, which is embedded in substrate 16, is shown interrogating into the derma of tissue 25 by directing emission of an RF signal or energy into the skin and receiving the signal and correspondingly reading the reflected signal. The interrogator or electronics
15 package 22 excites electrode coil 14 by providing the needed energy burst to support the scanning/reading of the tissue. Each embedded electrode 14 measures the equivalent sub-epidermal capacitance corresponding to the moisture content of the target skin 25.

20 **[0054]** While other energy modalities are contemplated (e.g. ultrasound, microwave, etc.), RF is generally preferred for its resolution in SEM scanning.

25 **[0055]** FIG. 10 illustrates a perspective view of an assembled SEM scanner 10 with an alternative substrate 16b having an array 14 of ten sensors dispersed within the substrate 16b. This larger array 14 provides for a larger scanning area of the subject anatomy, thus providing a complete picture of the target anatomy in one image without having to generate a scanning motion. It is appreciated that array 14 may comprise any number of individual sensors, in
be disposed in a variety of patterns.

30 **[0056]** The SEM scanner 10 was evaluated using a number of different sized and types of sensors 26. Table 1 illustrates electrode geometries are used throughout the following measurements. As shown in FIG. 1 the outer ring electrode diameter D_o varied from 5 mm for the XXS pad, to 55 mm for the

large pad. The outer ring electrode inner diameter D_i varied from 4 mm for the XXS pad, to 40 mm for the large pad. The inner electrode diameter D_c varied from 2 mm for the XXS pad, to 7 mm for the large pad. It is appreciated that the actual dimensions of the electrodes may vary from ranges shown in these experiments. For example, the contact diameter may range from 5 mm to 30 mm, and preferably ranges from 10 mm to 20 mm.

[0057] To measure the properties of each sensor size listed in Table 1, the sensors were fabricated using both Kapton and rigid board. In testing with the rigid sensor pads, lotion was applied to the thumb continuously for 15 minutes.

10 **[0058]** FIG. 11 is a plot of normalized responses of the tested electrodes of the present invention. The four sensors' (XXS, XS, S, M) normalized responses are compared in FIG. 11 and Table 2.

15 **[0059]** As can be seen in FIG. 11 and Table 2, the S electrode appears to be most responsive overall to the presence of moisture. Both the M and S electrodes seem to exhibit a peak. This suggests a depth dependency of the moisture being absorbed into the skin, as the roll-off from the M electrode occurs about 5 minutes after the peak for S electrode.

20 **[0060]** The SEM scanner 10 was also tested on the inner arm. A resistive pressure sensor (e.g. sensor 11 shown in FIG. 7) was also used to measure pressure applied on sensor to the arm. This way, constant pressure is applied across measurements. First, the dry inner arm was measured using the XS, S and M electrodes. Then, the same area was masked off with tape, and moisturizer lotion was applied for 30 minutes. Subsequent measurements were made on the same location after cleaning the surface.

25 **[0061]** FIG. 12 is a graph of measured equivalent capacitance for dry Volar arm for three different sized (M, S, XS) concentric sensor electrodes before applying the commercial lotion moisturizer.

30 **[0062]** FIG. 13 is a plot of time dependent fractional change in capacitance relative to dry skin for three different concentric sensor electrodes (after 30 minutes of applying lotion).

[0063] FIG. 14 is a plot of time dependent fractional change in capacitance

relative to dry skin for three different concentric sensor electrodes (after 15 minutes of applying lotion) on two subjects. This experiment was performed with faster sampling intervals and with lotion applied for 15 minutes only on forearms of two test subjects. Again, a resistive pressure sensor was used to measure pressure applied on sensor to the arm. This way, constant pressure is applied across measurements. First the dry inner arm was measured using the XS, S and M electrodes. Then the same area was masked off with tape, and lotion was applied for 15 minutes. Subsequent measurements were made on the same location every 5 minutes. Pressure was maintained at 50k Ohms, and the forearm was tested again. We noticed an interesting observation for the case "F" in comparison to case "A" and also compared to previous measurements. Case "F" took a shower right before running the measurements and hence as a result his skin was relatively saturated with moisture. As a result, we observed less degree of sensitivity to the applied deep moisturizer for case "F".

[0064] The experiment was performed again for case "F", with a time resolution of 3 minutes, knowing that the subject did not shower in the morning before the test. The lotion was applied to the inner forearm for 15 minutes. Pressure was maintained at 50k Ohms. The results confirm the sensitivity of the measurement to the residual skin moisture.

[0065] FIG. 15 is a plot of results for fractional change vs. time for M, S and XS electrodes.

[0066] FIG. 16 shows a preferred embodiment of a layered SEM scanner electrode system 100 having a first electrode pad 102 and second electrode pad 104. Pad 104 is connected to lead line inputs 116 via wiring 34 along curved path 112. Pad 102 is connected to lead line inputs 110 via wiring 34 along curved path 106. A stiffener layer (e.g. layer 126 in FIG. 5) is provided directly under lead inputs 110 and 116 (see footprint 108 and 114 respectively) and under pads 102 and 104 (see footprint 122 and 120 respectively).

[0067] In this embodiment, the electrode size is approximately 2300 in width by 3910 mil in height.

[0068] FIG. 17 illustrates the SEM Scanner mechanical compliance (force-displacement relationship) for electrodes of system 100, developed to enable probing of bony prominence. The diamond symbols show the upper electrode 104 response, square symbols show the lower electrode 102 response.

5 **[0069]** The SEM scanner device 10 may also include other instruments, such as a camera (not shown), which can be used to take pictures of the wound, or develop a scanning system to scan barcodes as a login mechanism or an interrogator.

10 **[0070]** Patients using the SEM scanner device 10 may wear a bracelet (not shown) that contains data relating to their patient ID. This ID can be scanned by the camera embedded in the SEM scanner 10 to confirm correct patient ID correspondence. Alternatively, a separate RF scanner (not shown) may be used for interrogating the bracelet (in addition to the camera).

15 **[0071]** The SEM scanner device 10 is preferably ergonomically shaped to encourage correct placement of the device on desired body location.

[0072] The SEM Scanner device 10 of the present invention is capable of generating physical, absolute measurement values, and can produce measurements at multiple depths.

20 **[0073]** From the foregoing it will be appreciated that the present invention can be embodied in various ways, which include but are not limited to the following:

25 **[0074]** 1. An apparatus for sensing sub-epidermal moisture from a location external to a patient's skin, comprising: a bipolar RF sensor embedded on a flexible substrate; a conformal pressure pad disposed adjacent and underneath the substrate; wherein the conformal pressure pad is configured to support the flexible substrate while allowing the flexible substrate to conform to a non-planar sensing surface of the patient's skin; and interface electronics coupled to the sensor; wherein said interface electronics is configured to control emission and reception of RF energy to interrogate the patient's skin.

30 **[0075]** 2. The apparatus of embodiment 1, further comprising: an annular spacer adjacent and underneath the conformal pressure pad; wherein the

annular spacer comprises a central opening configured to allow the conformal pressure pad to deflect freely into the central opening.

5 [0076] 3. The apparatus of embodiment 1, further comprising: an array of bipolar RF sensors spaced across the flexible substrate; wherein each of the sensors is independently coupled to the interface electronics to independently interrogate the patient's skin.

10 [0077] 4. The apparatus of embodiment 3: wherein each of the sensors is configured to measure an equivalent sub-epidermal capacitance of a target region of skin; said sub-epidermal capacitance corresponding to the moisture content of the target region of skin.

[0078] 5. The apparatus of embodiment 4: wherein the array of sensors comprises a first sensor having a first contact area and a second sensor having a second contact area larger than the first sensor; wherein the first and second sensors interrogate the skin at different depths.

15 [0079] 6. The apparatus of embodiment 4: wherein the substrate comprises a substrate assembly comprising a substrate layer; and wherein the sensor comprises a sensing pad having a first electrode embedded on a first side of the substrate and a second electrode embedded on a second side of the substrate.

20 [0080] 7. The apparatus of embodiment 6, further comprising a biocompatible cover layer disposed over said first side of said substrate layer.

[0081] 8. The apparatus of embodiment 6, further comprising a cover layer disposed under said second side of said substrate layer.

25 [0082] 9. The apparatus of embodiment 6, further comprising a stiffener layer disposed under said second side of said substrate layer; wherein the stiffener layer comprises a footprint substantially similar to that of the sensor array.

30 [0083] 10. The apparatus of embodiment 6: wherein said first electrode comprises an annular ring having an inner radius and an outer radius; wherein said second electrode comprises an outer radius having a smaller diameter than the inner radius of the first electrode; and wherein said second electrode is concentric with said first radius.

[0084] 11. The apparatus of embodiment 1, wherein the interface electronics are configured to transmit data retrieved from said sensors.

[0085] 12. The apparatus of embodiment 4, further comprising: a pressure sensor positioned in line with said RF sensor; said pressure sensor configured to measure an applied pressure of the substrate at a location on the patient's skin.

[0086] 13. The apparatus of embodiment 1, wherein the flexible substrate comprises Kapton or Polyimide.

[0087] 14. A scanner for sensing sub-epidermal moisture from a location external to a patient's skin, comprising: an array of bipolar RF sensors embedded on a flexible substrate; and a conformal pressure pad disposed adjacent and underneath the substrate; wherein the conformal pressure pad is configured to support the flexible substrate while allowing the flexible substrate to conform to a non-planar sensing surface of the patient's skin; wherein said sensor array is configured to emit and receive RF energy to interrogate the patient's skin; and wherein each of the sensors are independently are individually wired to independently interrogate the patient's skin.

[0088] 15. The scanner of embodiment 14, further comprising: interface electronics coupled to the sensor; wherein said interface electronics is configured to control the emission and reception of RF energy.

[0089] 16. The scanner of embodiment 14, further comprising: an annular spacer adjacent and underneath the conformal pressure pad; wherein the annular spacer comprises a central opening configured to allow the conformal pressure pad to deflect freely into the central opening.

[0090] 17. The scanner of embodiment 14: wherein each of the sensors is configured to measure an equivalent sub-epidermal capacitance of a target region of skin; said sub-epidermal capacitance corresponding to the moisture content of the target region of skin.

[0091] 18. The scanner of embodiment 14: wherein the array of sensors comprises a first sensor having a first contact area and a second sensor having a second contact area larger than the first sensor; and wherein the first

and second sensors interrogate the skin at different depths.

5 [0092] 19. The scanner of embodiment 14: wherein each sensor comprises a first electrode in the form of an annular ring having an inner radius and an outer radius and a second electrode comprising an outer radius having a smaller diameter than the first electrode; and wherein said second electrode is concentric with said first radius.

10 [0093] 20. The scanner of embodiment 19: wherein the substrate comprises a substrate assembly comprising a substrate layer; and wherein the first electrode is embedded on a first side of the substrate and the second electrode embedded on a second side of the substrate.

[0094] 21. The scanner of embodiment 20, further comprising: an upper biocompatible cover layer disposed over said first side of said substrate layer and a lower cover layer disposed under said second side of said substrate layer.

15 [0095] 22. The scanner of embodiment 20, further comprising: a stiffener layer disposed under said second side of said substrate layer; wherein the stiffener layer comprises a footprint substantially similar to that of the sensor array.

20 [0096] 23. The scanner of embodiment 14, further comprising: an array of pressure sensors positioned in line with said RF sensor; said pressure sensors are configured to measure an applied pressure of the substrate at corresponding locations on the patient's skin.

25 [0097] 24. A method for monitoring the formation of pressure ulcers at a target location of a patient's skin, comprising: positioning a flexible substrate adjacent the target location of the patient's skin; the flexible substrate comprising one or more bipolar RF sensors; conforming the flexible substrate to the patient's skin at the target location; exciting the one or more bipolar RF sensor to emit RF energy into the patient's skin; and measuring the capacitance of the skin at the target location as an indicator of the Sub-Epidermal Moisture (SEM) at the target location.

30 [0098] 25. The method of embodiment 24: wherein the one or more sensors comprise an array of sensors disposed across said substrate; and wherein the

one or more sensors are individually controlled to independently excite the one or more sensors.

[0099] 26. The method of embodiment 24, further comprising: measuring an applied pressure of the substrate at the target location on the patient's skin.

5 [00100] 27. The method of embodiment 25, further comprising: measuring an applied pressure of the substrate on the patient's skin at each of the sensors in the array.

[00101] Although the description above contains many details, these should not be construed as limiting the scope of the invention but as merely providing illustrations of some of the presently preferred embodiments of this invention. Therefore, it will be appreciated 10 that the scope of the present invention fully encompasses other embodiments which may become obvious to those skilled in the art, and that the scope of the present invention is accordingly to be limited by nothing other than the appended claims, in which reference to an element in the singular is not intended to mean "one and only one" unless explicitly so stated, but rather "one or more." All structural, chemical, and functional equivalents to the 15 elements of the above-described preferred embodiment that are known to those of ordinary skill in the art are intended to be encompassed by the present claims. Moreover, it is not necessary for a device or method to address each and every problem sought to be solved by the present invention, for it to be encompassed by the present claims. Furthermore, no element, component, or method step in the present disclosure is intended to be dedicated 20 to the public regardless of whether the element, component, or method step is explicitly recited in the claims.

Table 1

Symbol	XXS	XS	S	M	L
Contact Diameter (mm)	5	10	20	23	55
Approx Outer D_o (mm)	5	10	20	23	55
Approx Middle D_i (mm)	4	6	10	15	40
Approx Inner D_c (mm)	2	2	4	5	7

Table 2
Tabulated Normalized Responses of M, S, XS and XXS Electrodes

Time	M	M Baseline	S	S Baseline	XS	XS Baseline	XXS	XXS Baseline
0	2.32	2.04	1.89	1.5	0.261	0.24	1.12	1.04
5	2.32	2.04	1.9	1.5	0.256	0.24	1.1	1.04
10	2.38	2.04	1.92	1.5	0.259	0.24	1.07	1.04
15	2.4	2.04	1.99	1.5	0.255	0.24	1.06	1.04
20	2.39	2.04	1.93	1.5	0.248	0.24	1.05	1.04
25	2.25	2.04	1.92	1.5	0.25	0.24	1.04	1.04
30	2.21	2.04	1.88	1.5	0.248	0.24	1.04	1.04
35	2.18	2.04	1.86	1.5	0.245	0.24	1.04	1.04

We claim:

1. A Sub-Epidermal Moisture (SEM) sensing apparatus, comprising:
 - a substrate comprising a rigid stiffener,
 - a first electrode and a second electrode that are both fixedly coupled to the substrate,
 - an insulating cover layer fixedly disposed over the first and second electrodes and is configured to act as a barrier between a tissue being measured and the first and second electrodes, and
 - an electronics package that is electrically coupled to the first and second electrodes, and the electronics package is configured to measure a capacitance between the first and second electrodes,

wherein the capacitance is an indicator of the SEM.
2. The SEM sensing apparatus of claim 1, wherein the second electrode is an annular electrode that is disposed around the first electrode.
3. The SEM sensing apparatus of claim 1, wherein the first and second electrodes are electrically insulated by the insulating cover layer.
4. The SEM sensing apparatus of claim 3, wherein the first and second electrodes are electrically insulated from each other.
5. The SEM sensing apparatus of claim 3, wherein the insulating cover layer comprises a Pyralux FR coverlay.
6. The SEM sensing apparatus of claim 1, wherein the first and the second electrodes are coupled to the electronic package as to form a bipolar RF sensor.
7. A Sub-Epidermal Moisture (SEM) sensing apparatus, comprising:
 - a substrate comprising a rigid stiffener,

a first electrode and a second electrode that are both fixedly coupled to the substrate,

an insulating cover layer fixedly disposed over both the first and second electrodes and is configured to act as a barrier between a tissue being measured and the first and second electrodes,

a pressure sensor that is coupled to the substrate and configured to sense a pressure that is applied to the substrate, and

an electronics package that is electrically coupled to the first and second electrodes and the pressure sensor, and the electronics package is configured to:

measure a pressure as sensed by the pressure sensor,

and

measure a capacitance between the first and second electrodes when the pressure is within a defined pressure range,

wherein the capacitance is an indicator of the SEM.

8. The SEM sensing apparatus of claim 7, further comprising an enclosure, and wherein the substrate is movably coupled to the enclosure.

9. The SEM sensing apparatus of claim 8, wherein the pressure sensor is disposed between the enclosure and the substrate.

10. The SEM sensing apparatus of claim 9, wherein the pressure sensor is disposed in line with the first and second electrodes.

11. The SEM sensing apparatus of claim 8, wherein the electronics package is disposed within the enclosure.

12. The SEM sensing apparatus of claim 7, wherein the second electrode is an annular electrode that is disposed around the first electrode.

13. The SEM sensing apparatus of claim 12, wherein the second electrode is concentrically disposed around the first electrode.

14. The SEM sensing apparatus of claim 12, wherein the first electrode and the second electrode are configured such that there is an annular gap between the first and second electrodes.

15. The SEM sensing apparatus of claim 14, wherein the annular gap is uniform.

16. The SEM sensing apparatus of claim 7, wherein the substrate comprises a first side, and wherein the first and second electrodes and the insulating cover layer are all coupled to the first side of the substrate.

17. The SEM sensing apparatus of claim 7, wherein the first and second electrodes are electrically insulated from each other.

18. The SEM sensing apparatus of claim 7, wherein the substrate comprises a second side, and wherein the pressure sensor is coupled to the second side of the substrate.

19. The SEM sensing apparatus of claim 7, wherein the electronics package is configured to measure the capacitance between the first and second electrodes by emitting and receiving radio frequency (RF) energy.

20. The SEM sensing apparatus of claim 19, wherein the first and the second electrodes are coupled to the electronic package as to form a bipolar RF sensor.

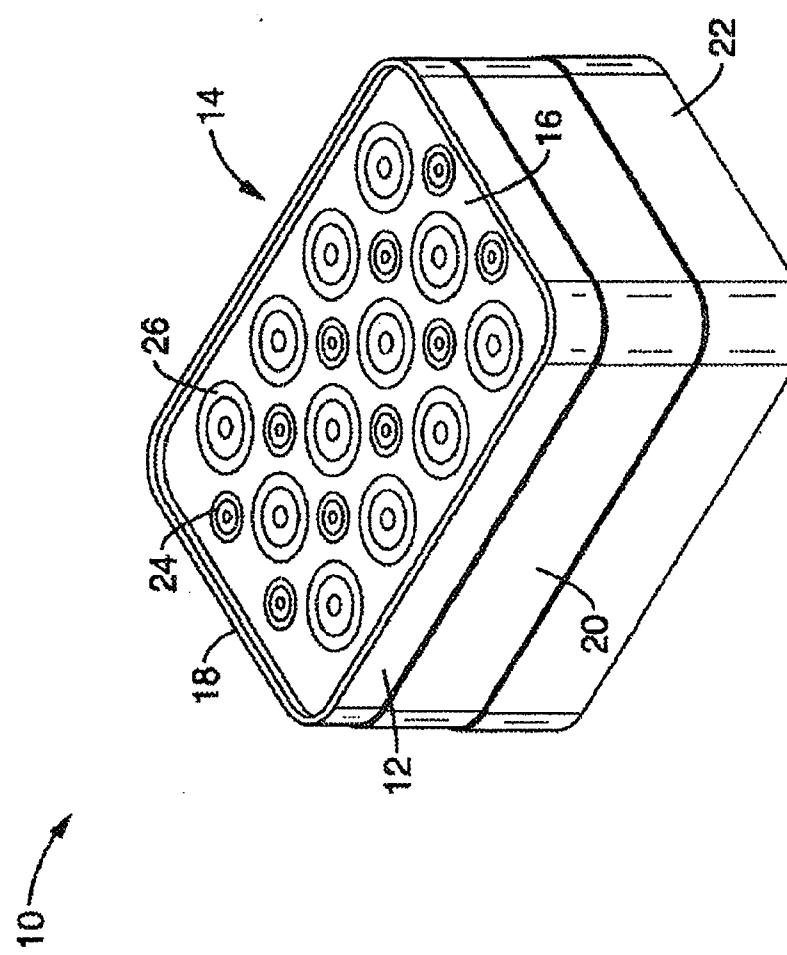


FIG. 1

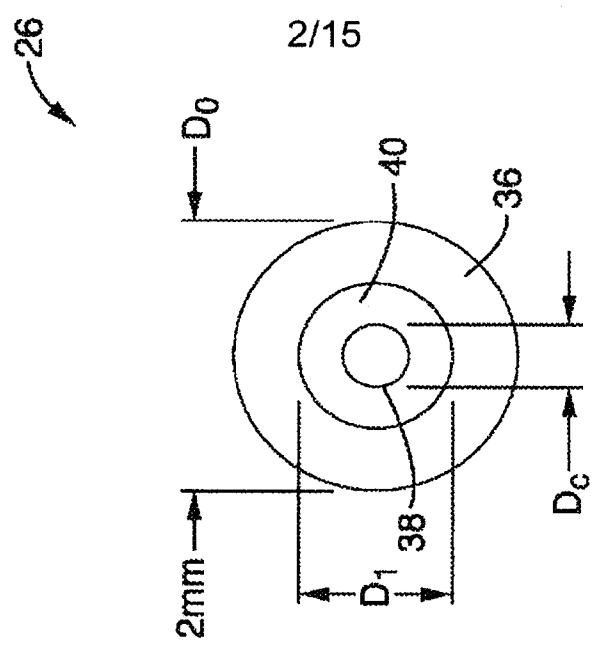


FIG. 3

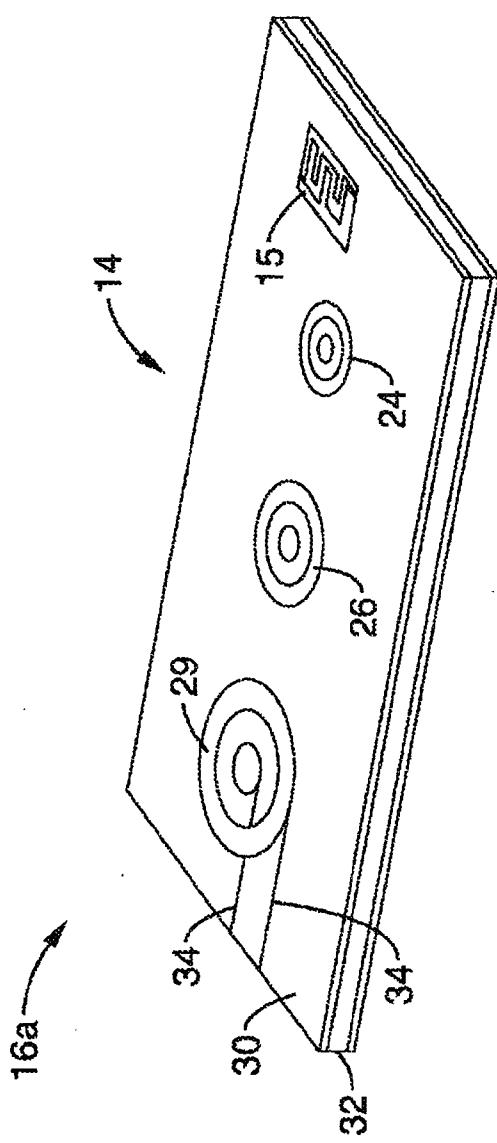
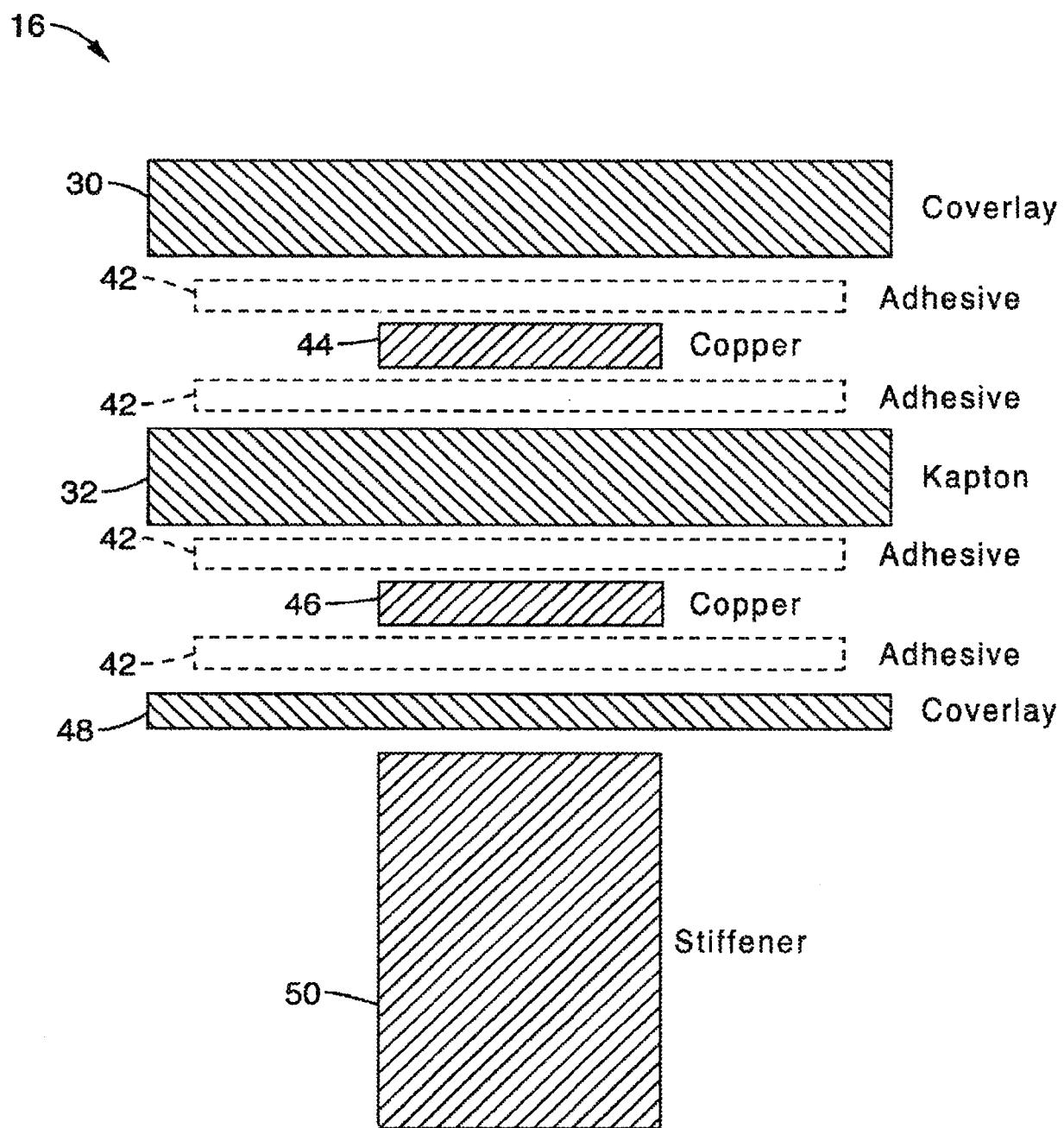
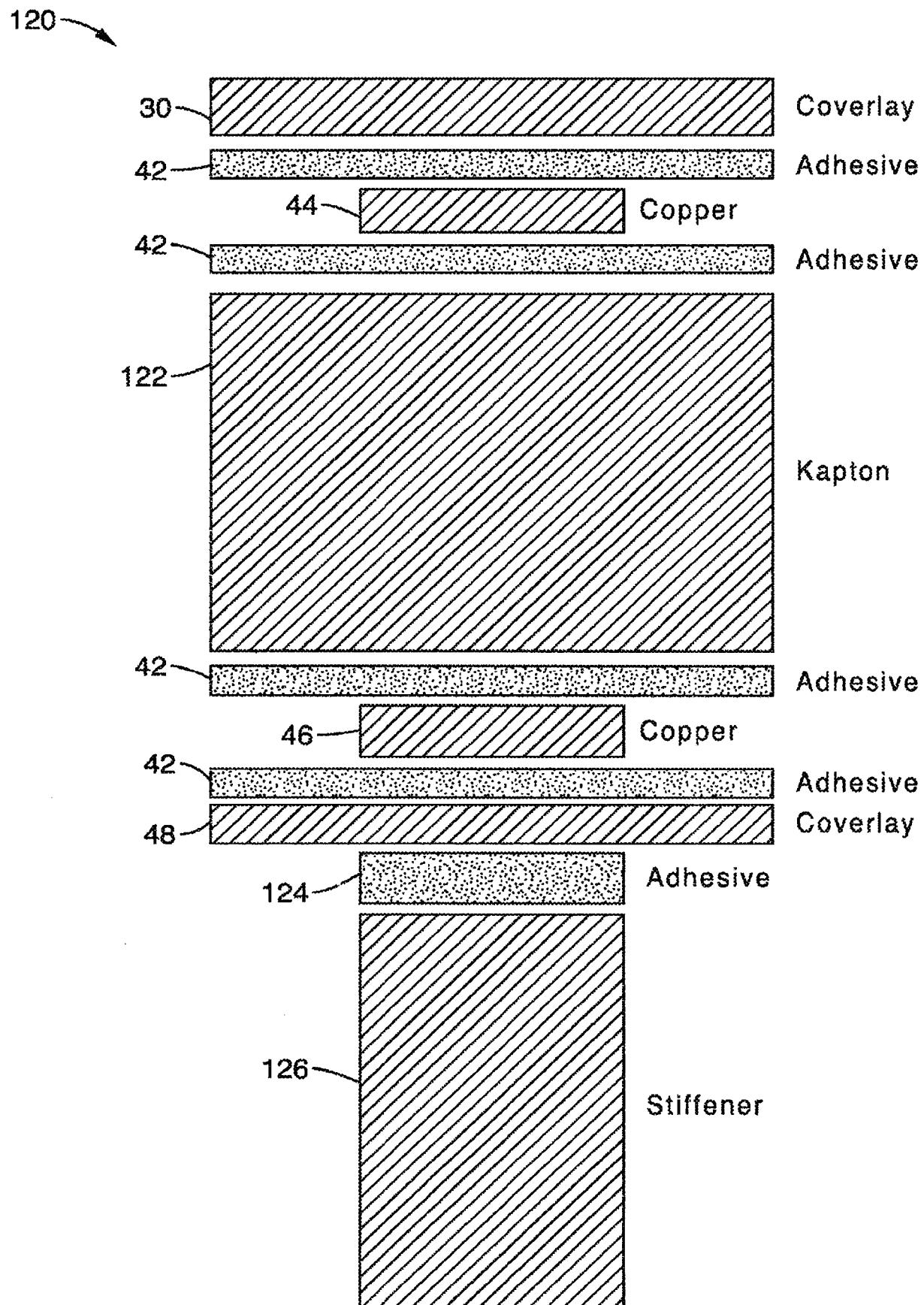


FIG. 2

3/15

**FIG. 4**

4/15



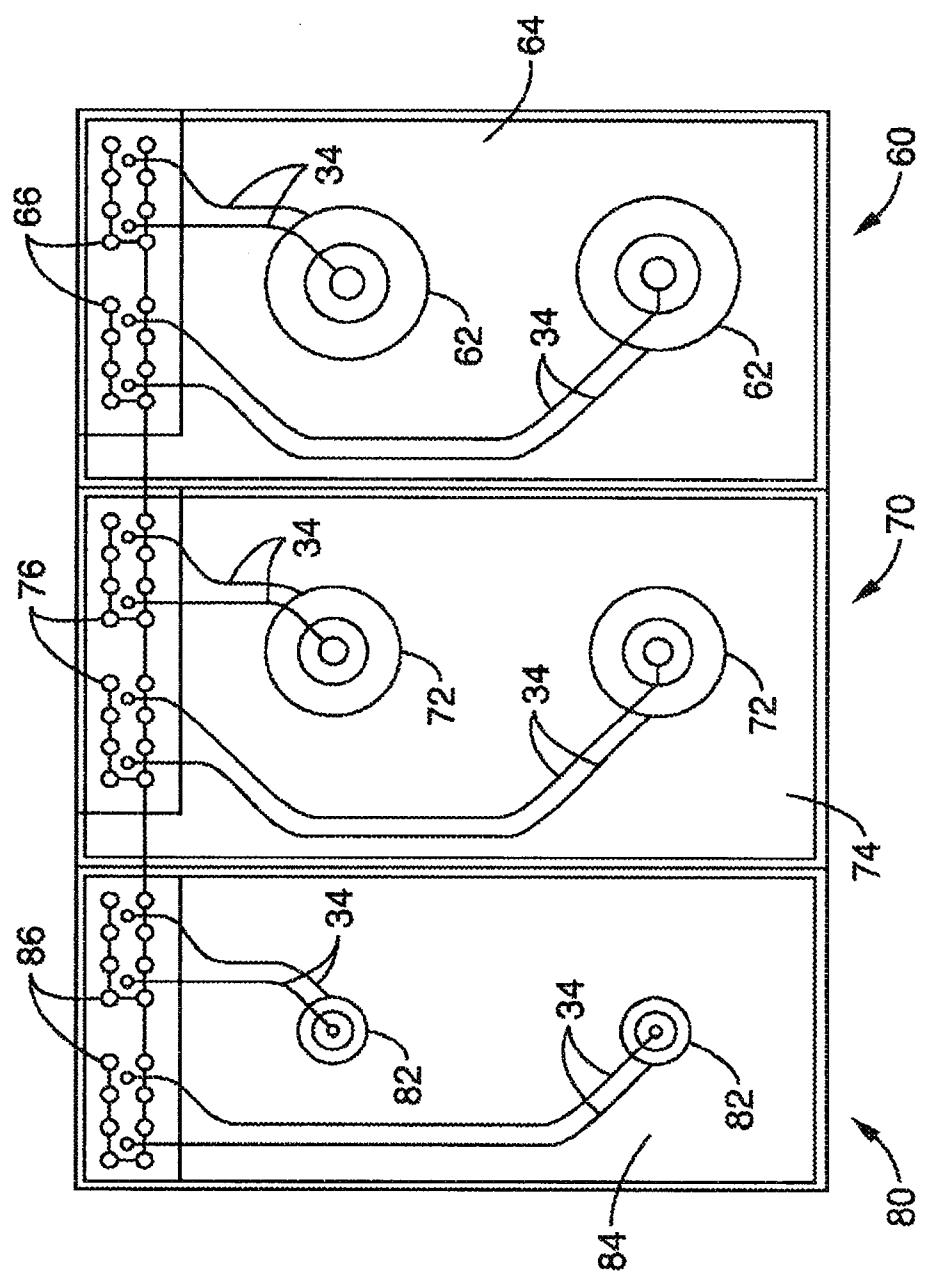


FIG. 6

6/15

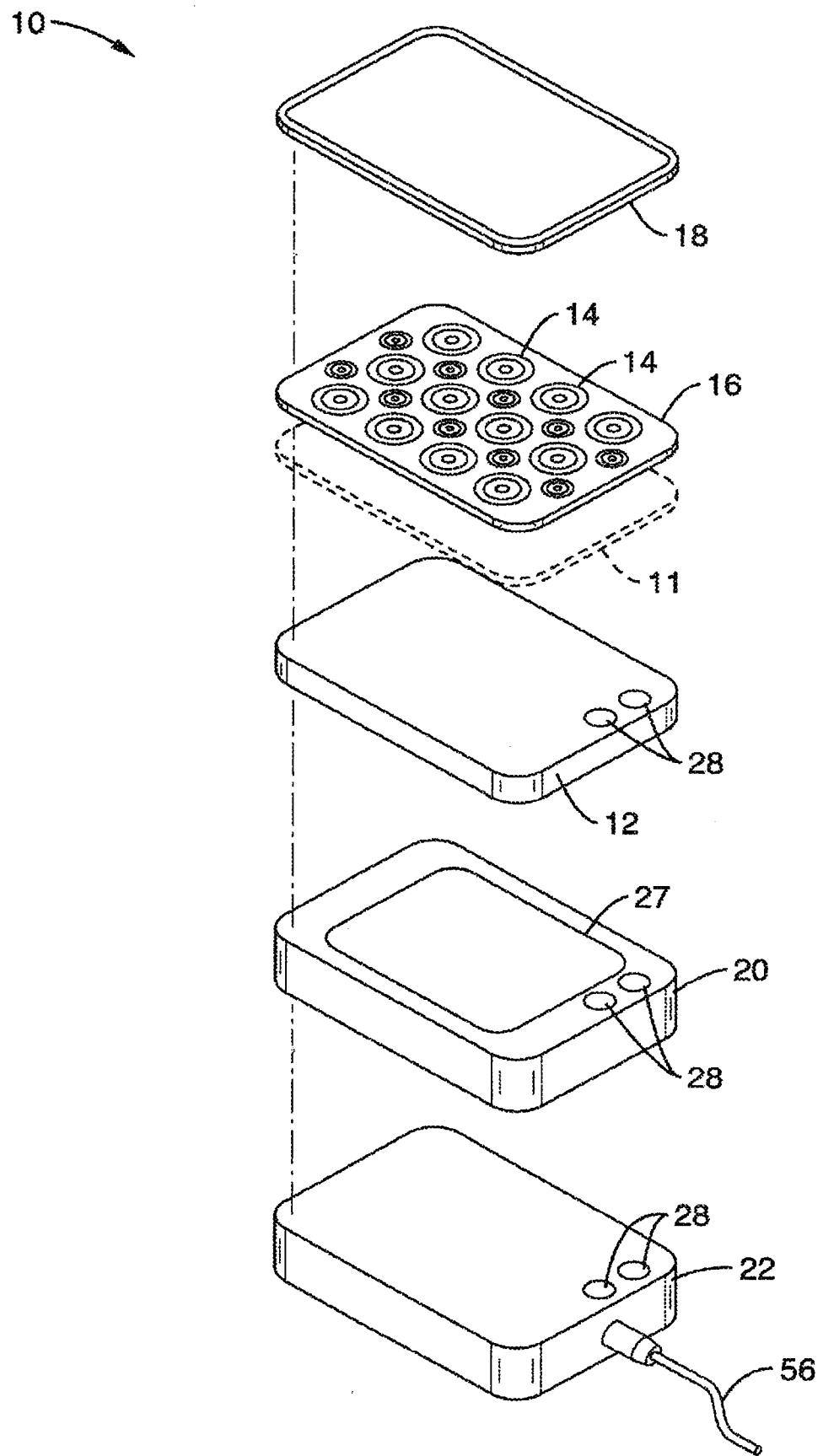


FIG. 7

7/15

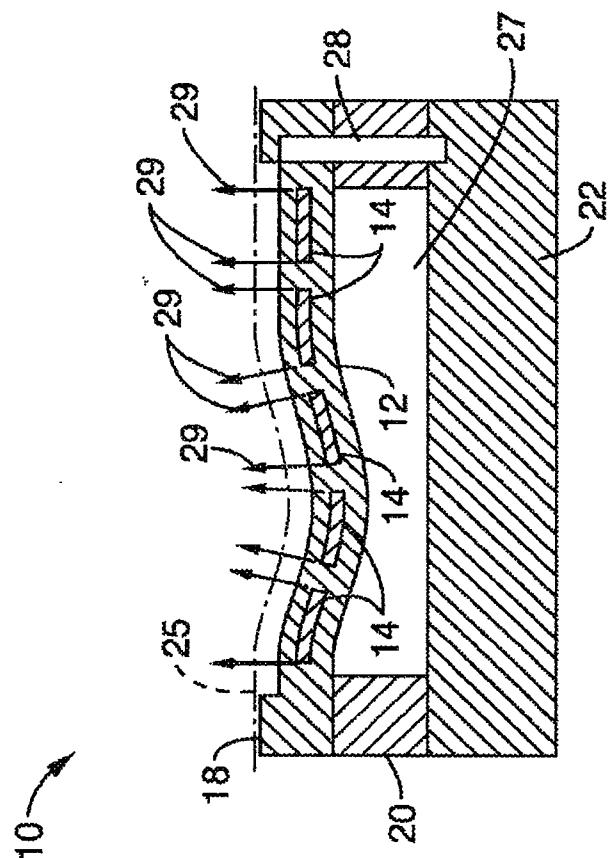


FIG. 9

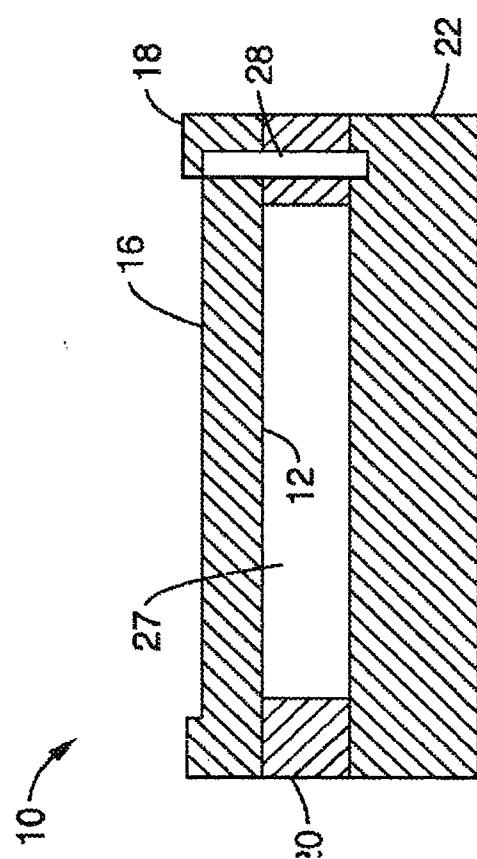


FIG. 8

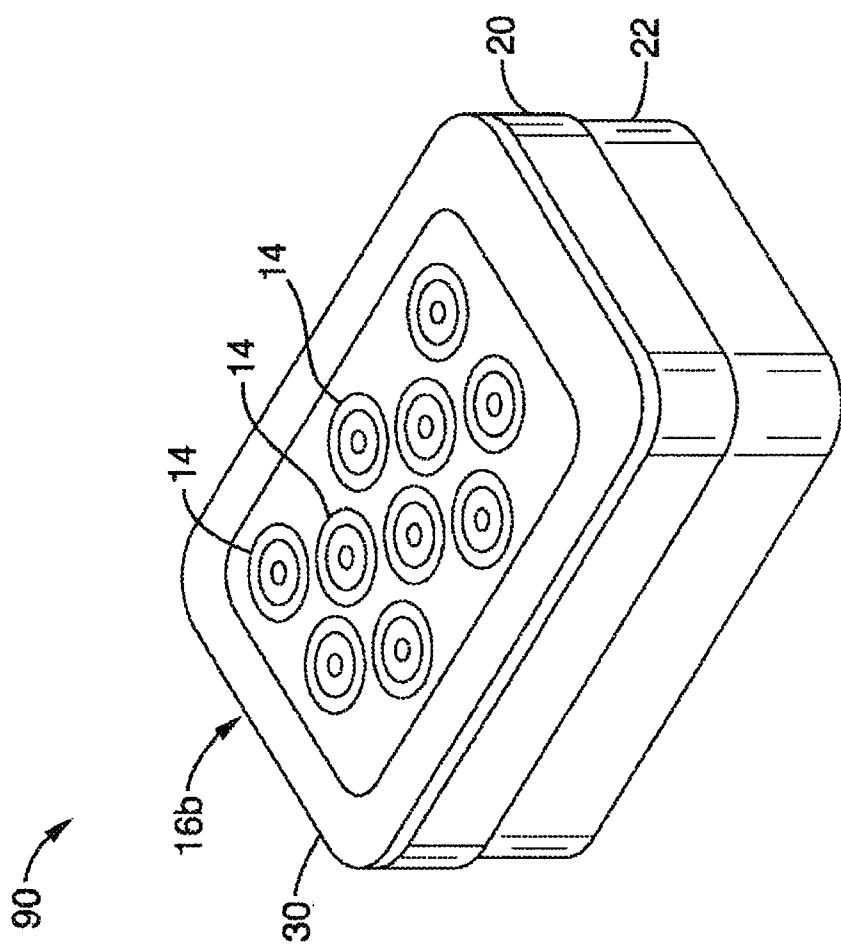


FIG. 10

9/15

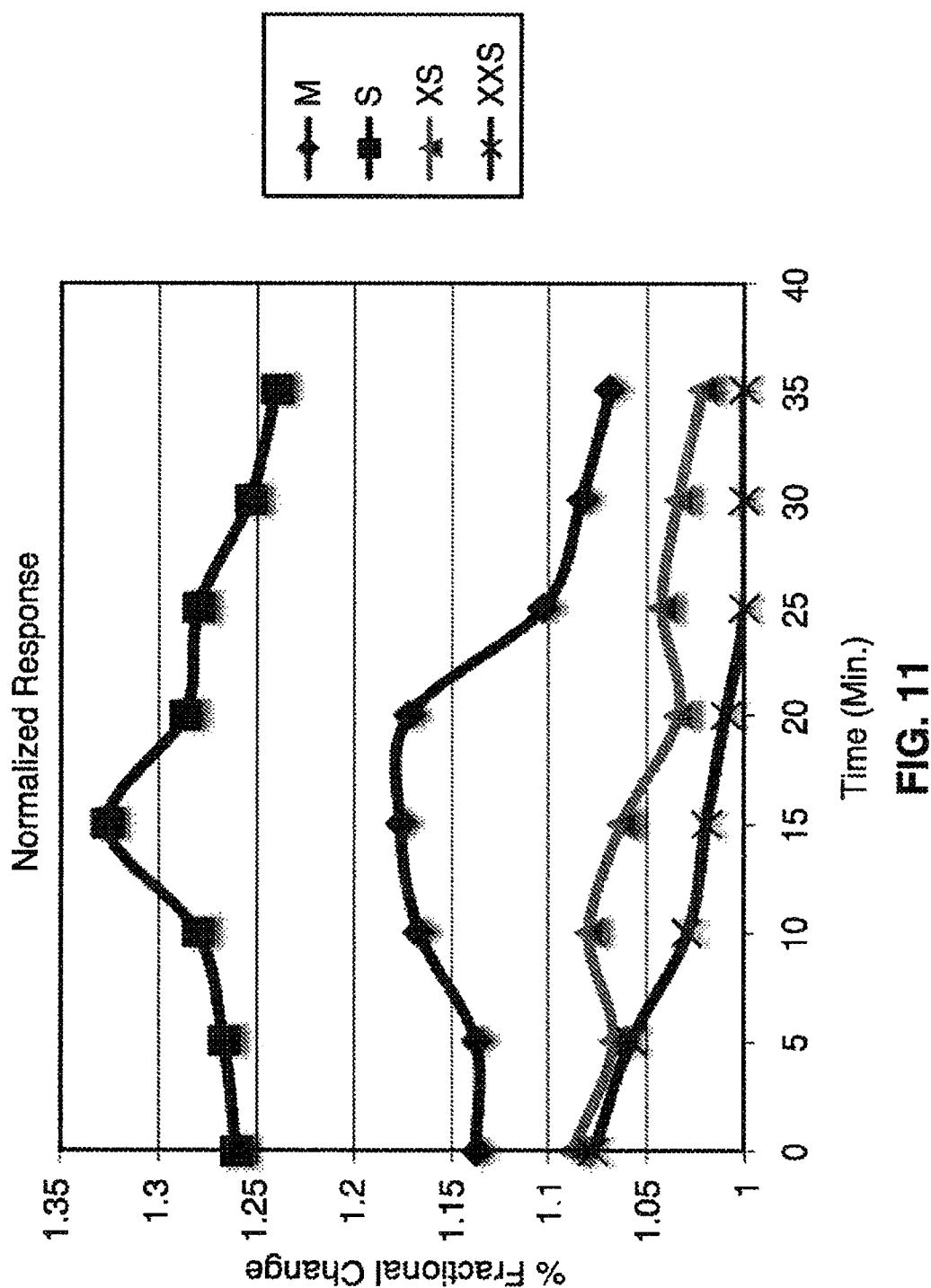
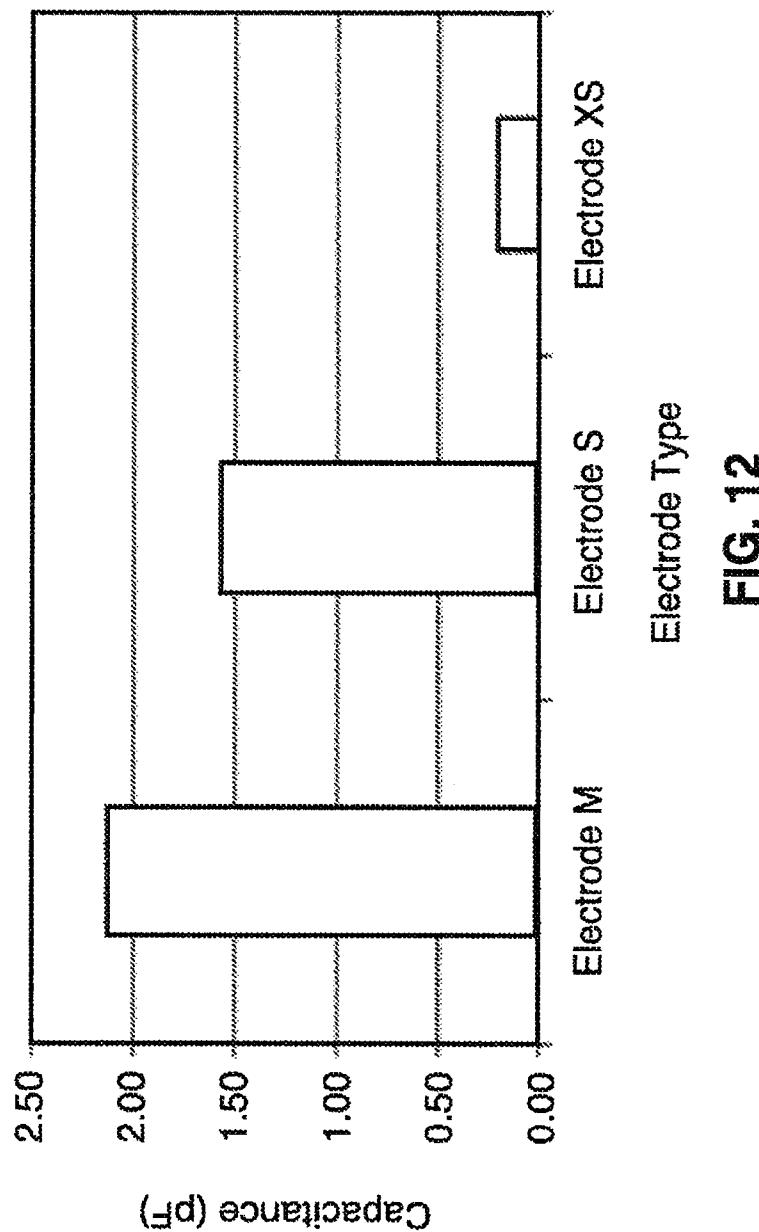


FIG. 11

10/15

**FIG. 12**

11/15

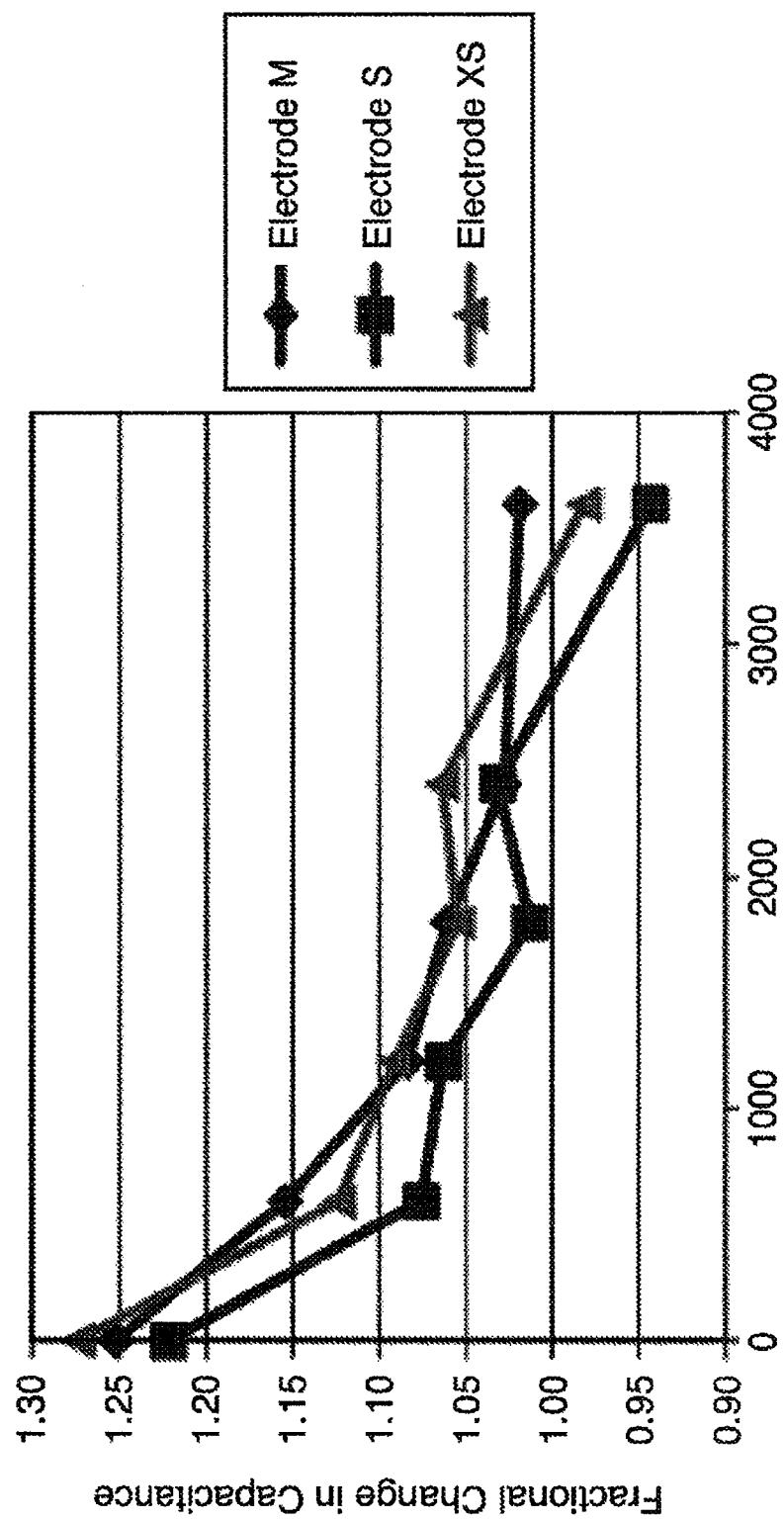
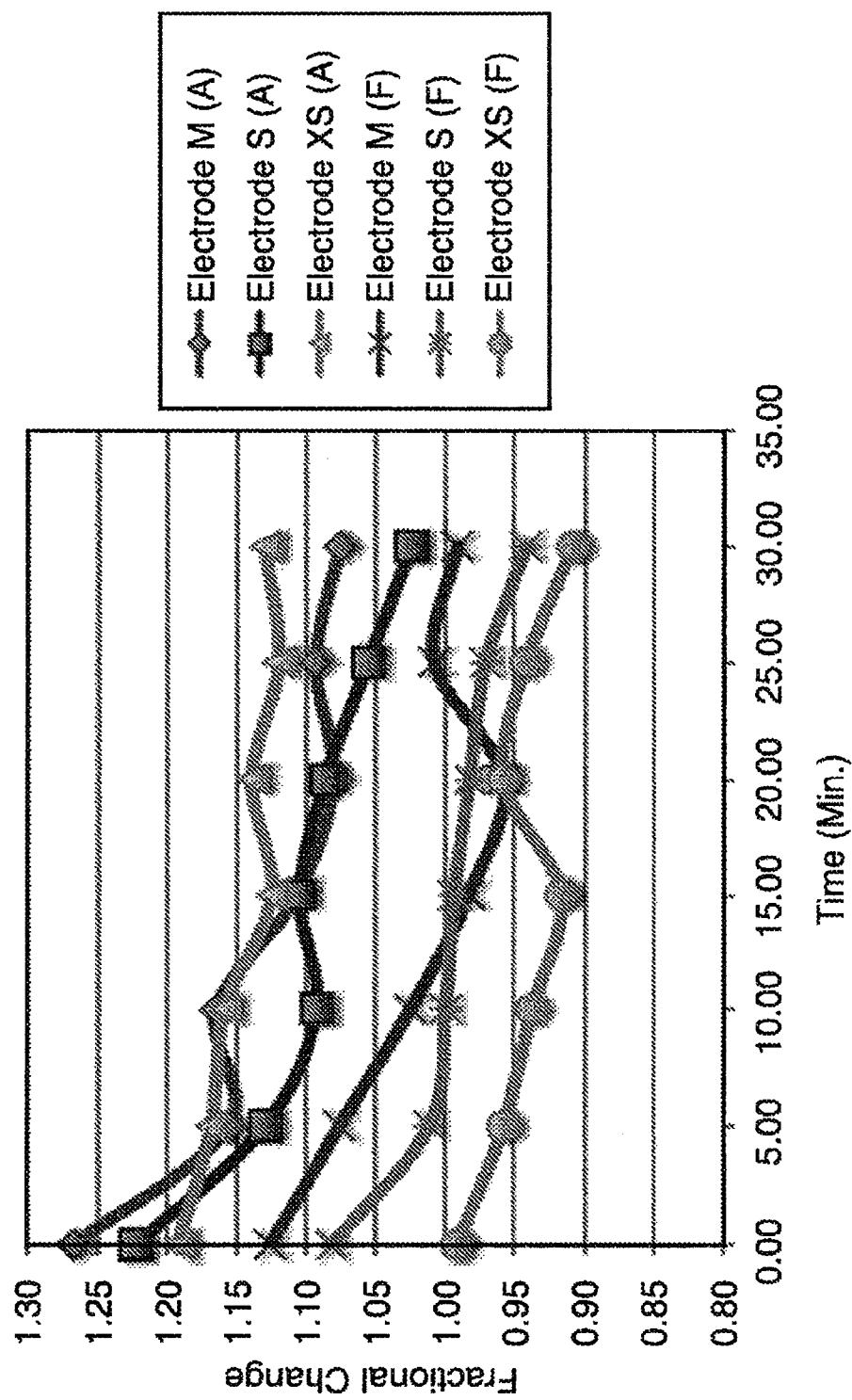


FIG. 13

12/15

**FIG. 14**

13/15

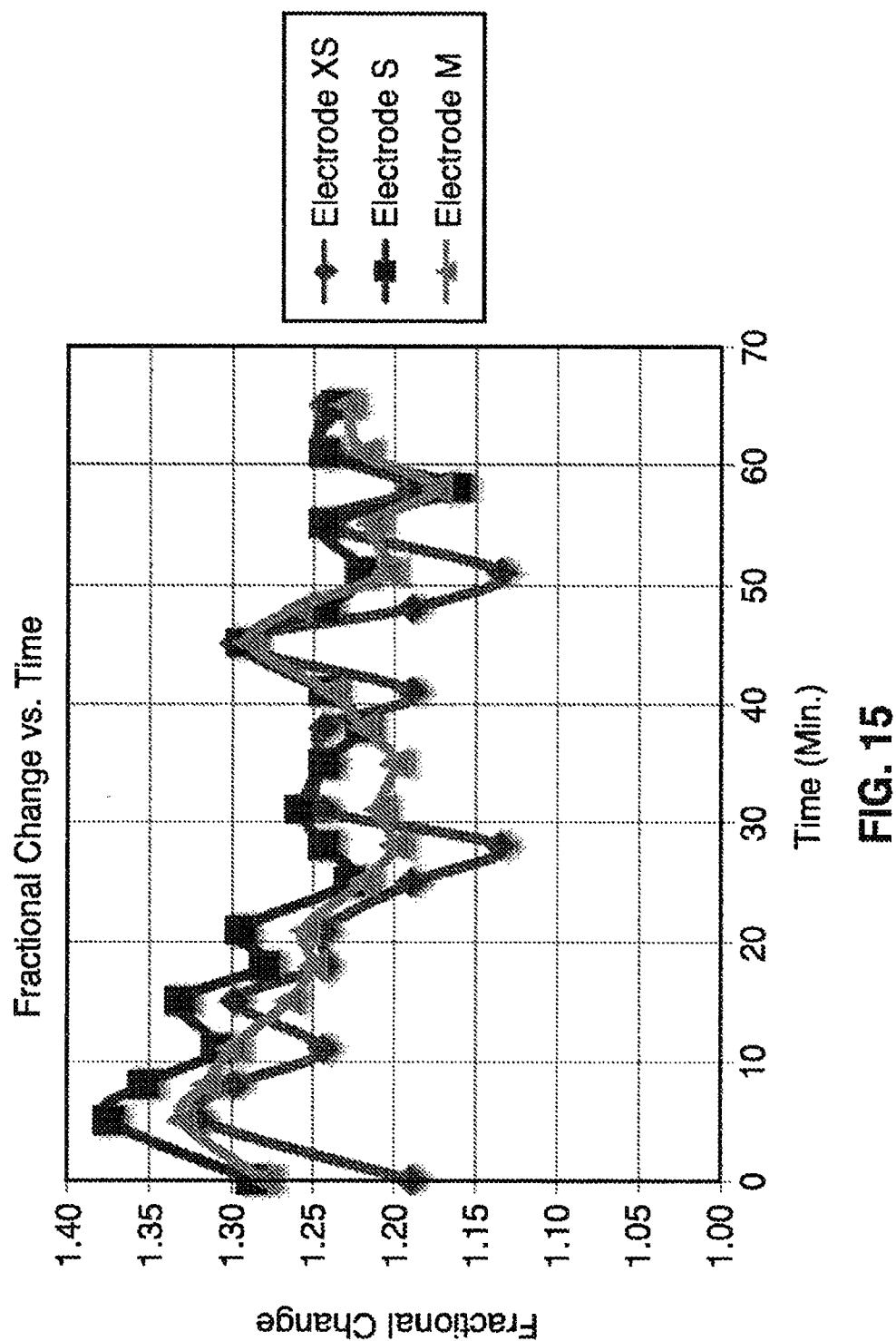
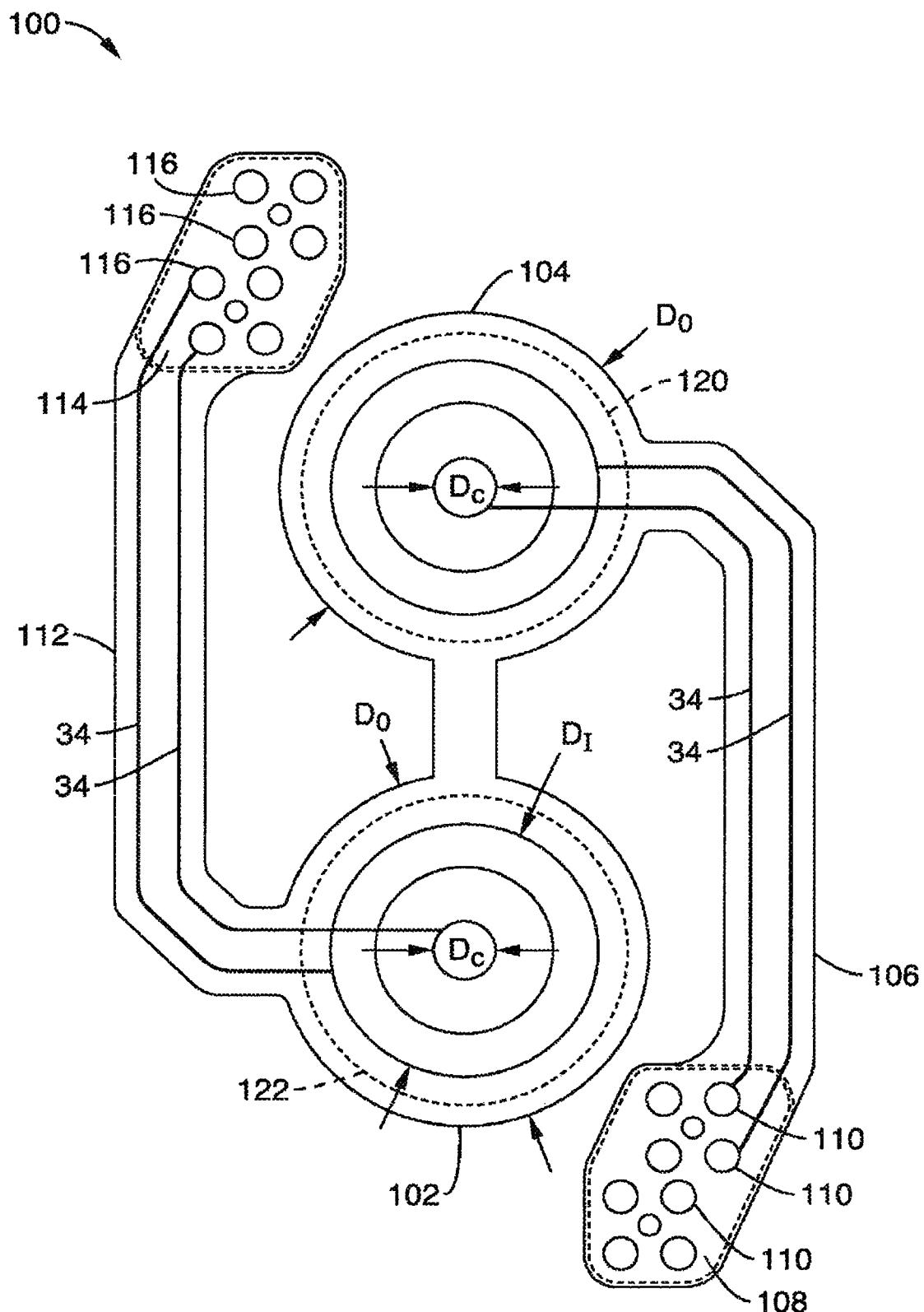


FIG. 15

14/15

**FIG. 16**

15/15

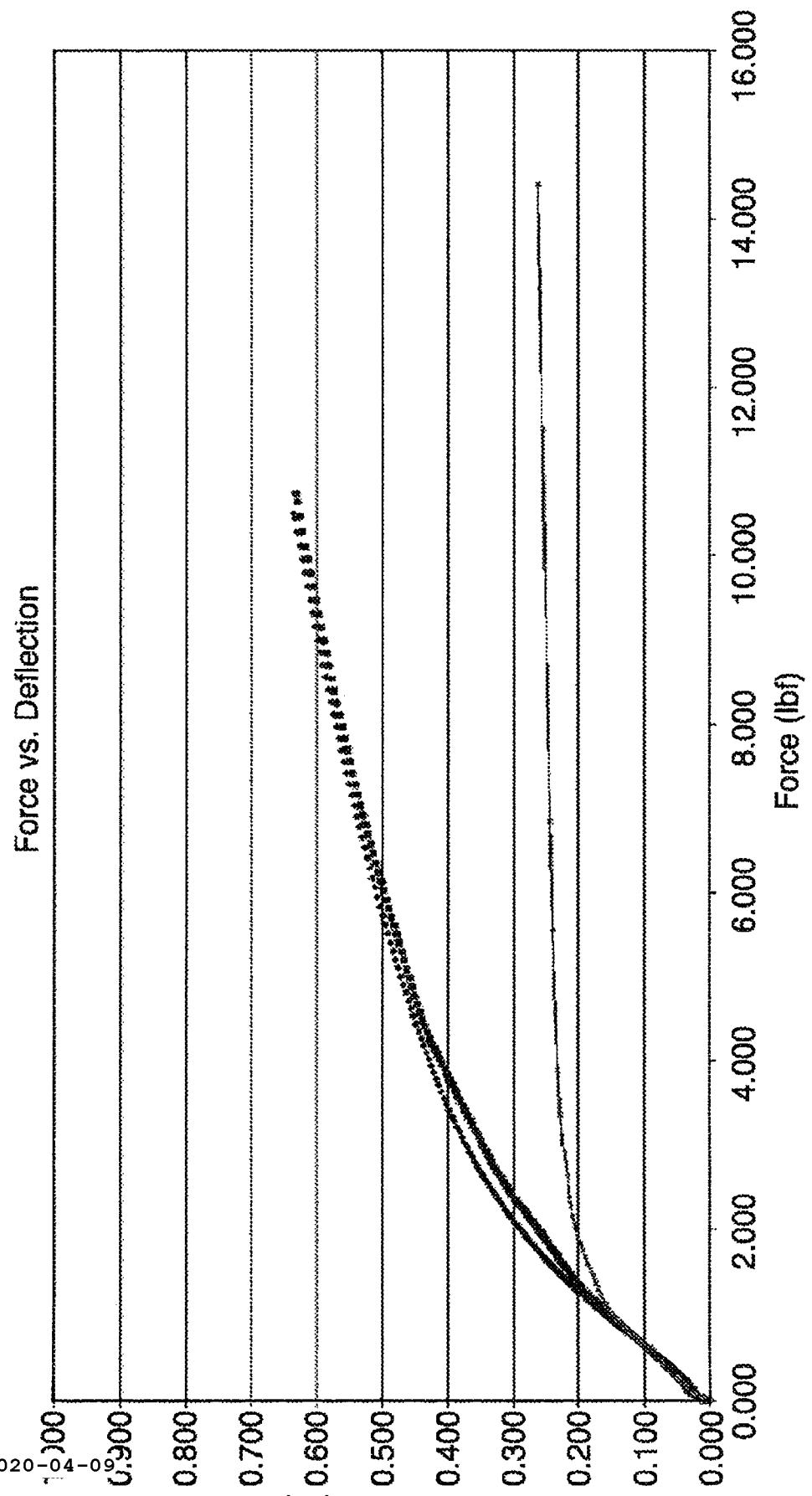


FIG. 17

10

